

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Toshitaka SHIMAMOTO et al.

International Application No.: PCT/JP2005/020927

International Filing Date: 15 November 2005

Priority Date Claimed: 22 November 2004

For: NITRIDE-BASED SEMICONDUCTOR DEVICE AND
METHOD FOR FABRICATING THE SAME

Examiner: Not Yet Assigned

Art Unit: Not Yet Assigned

**Mail Stop PCT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

PRELIMINARY AMENDMENT

Sir:

Entry of the following amendments prior to calculation of the filing fee and examination is respectfully requested.